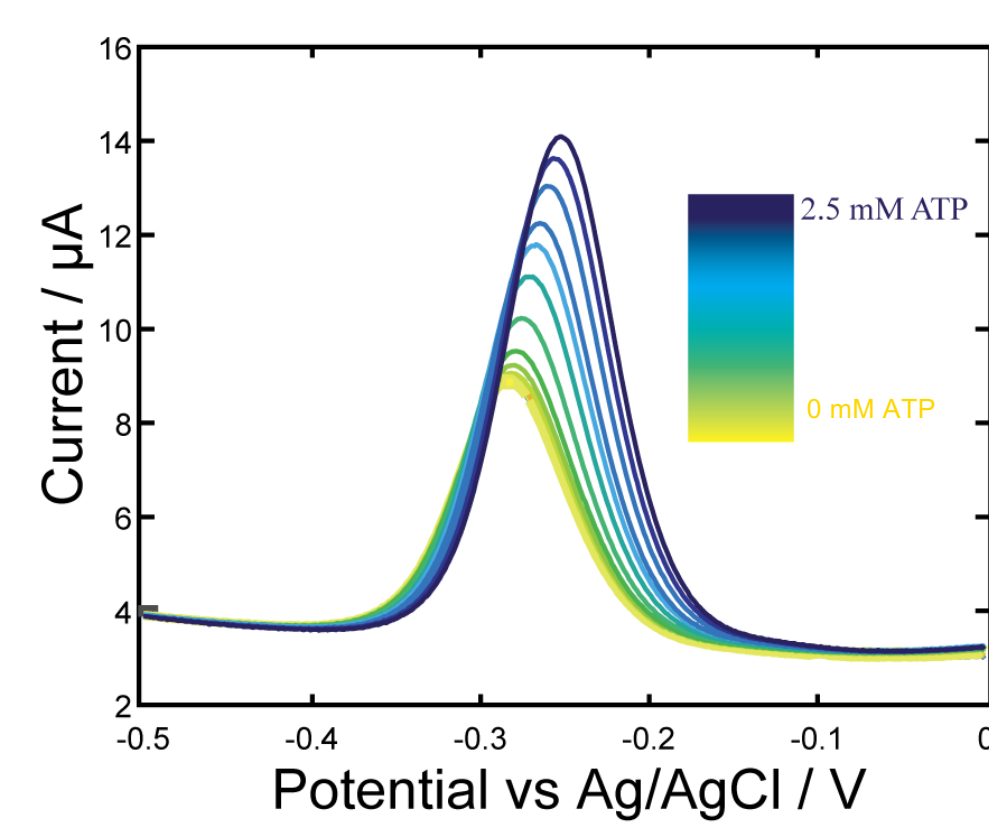


Electrochemical, Aptamer-Based Sensing

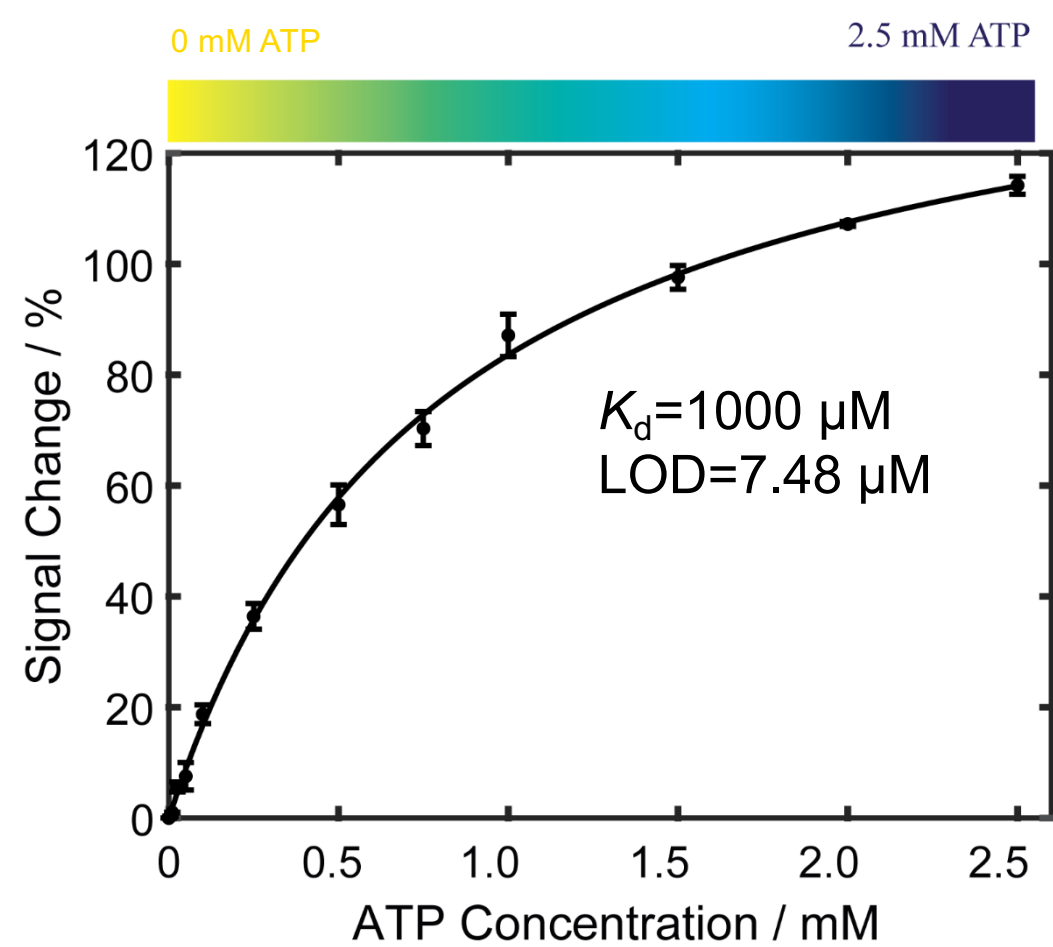
Why EAB Sensing?

- Reagentless
- Reversible analytical detection
- Highly specific
- Gives rapid results in real time

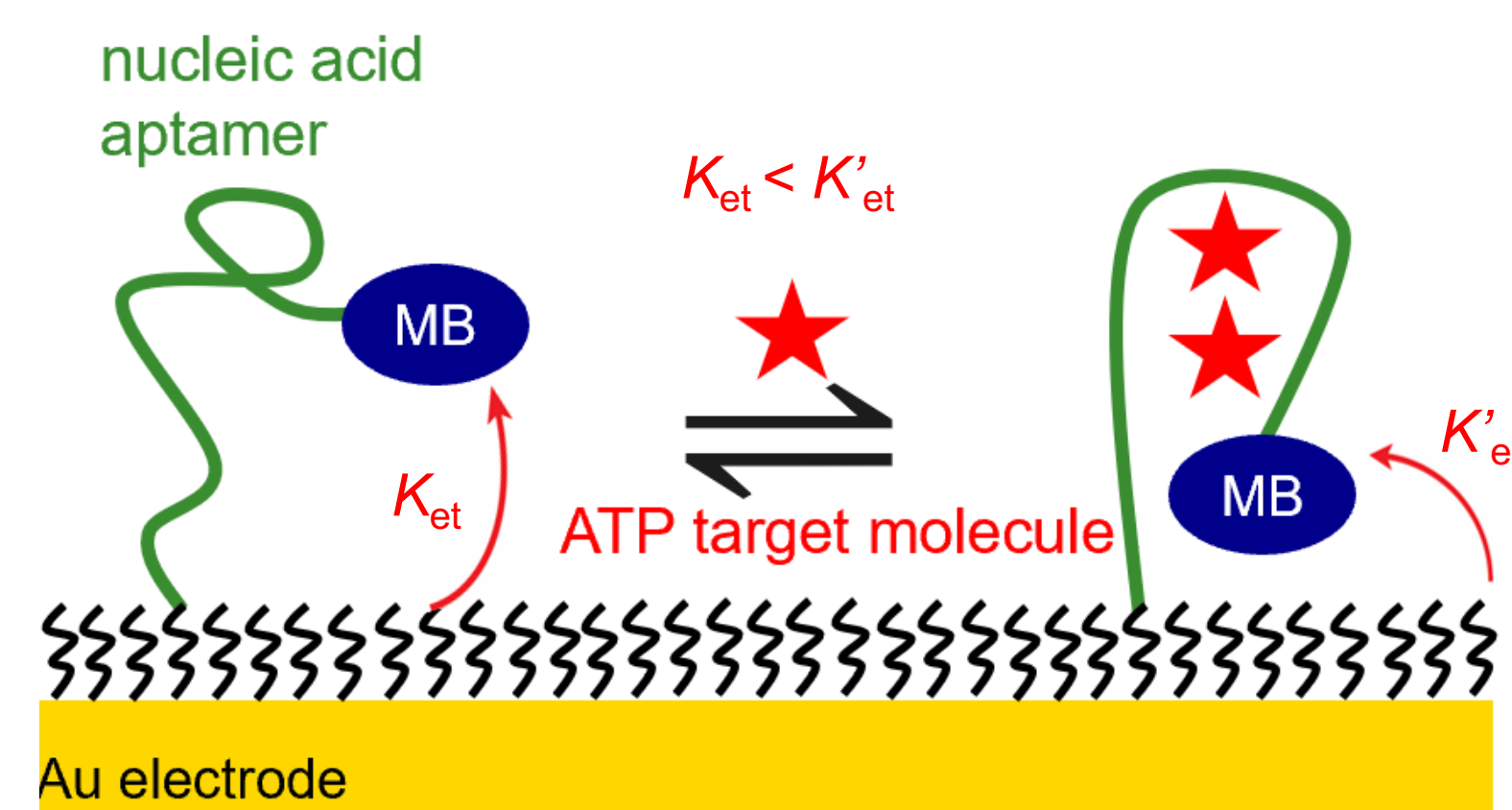
Square wave voltammograms (SWVs) for detecting ATP



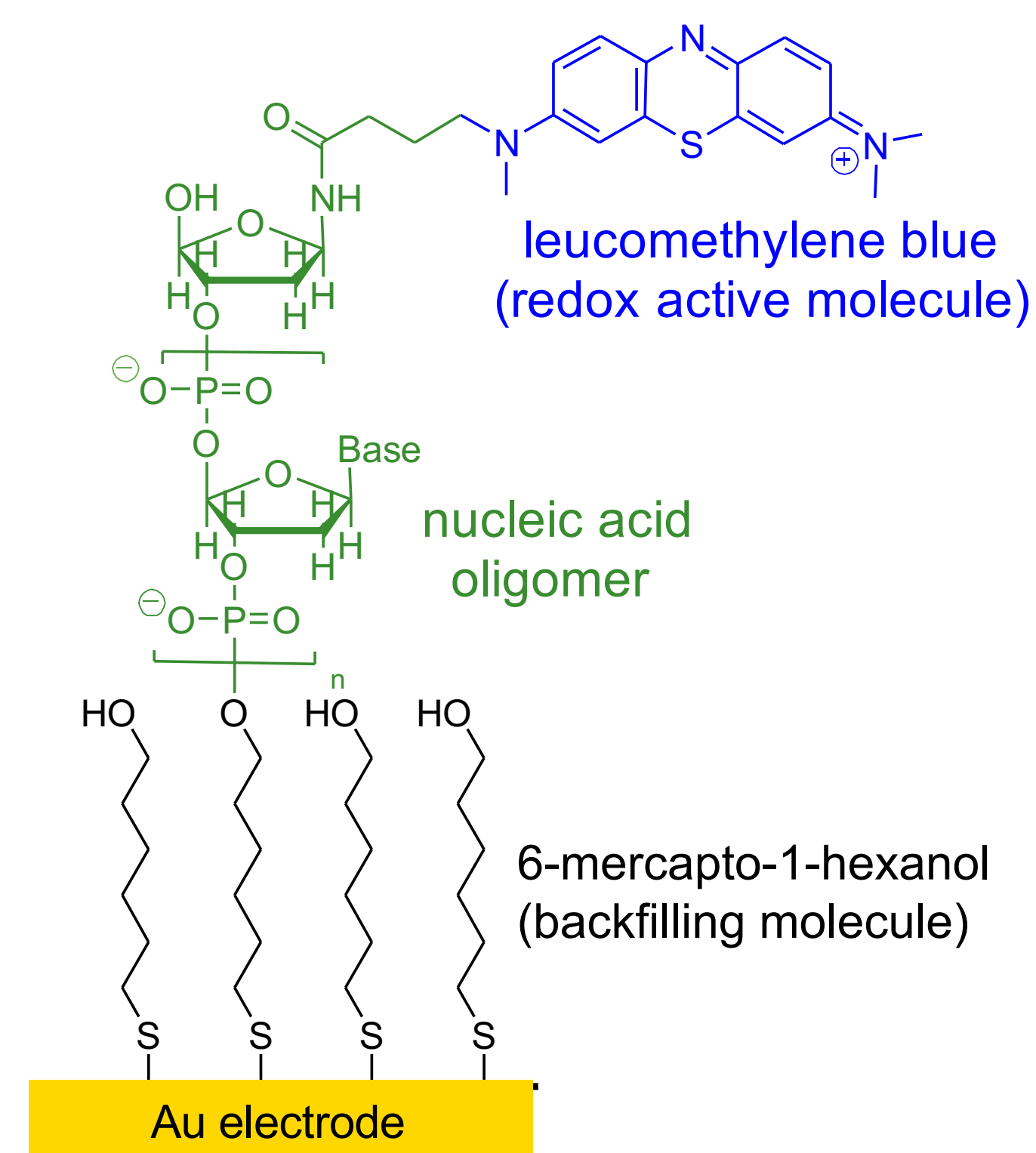
Langmuir isotherm calibration curve for quantifying sensor performance



Schematic of analyte detection



Components of an EAB sensor



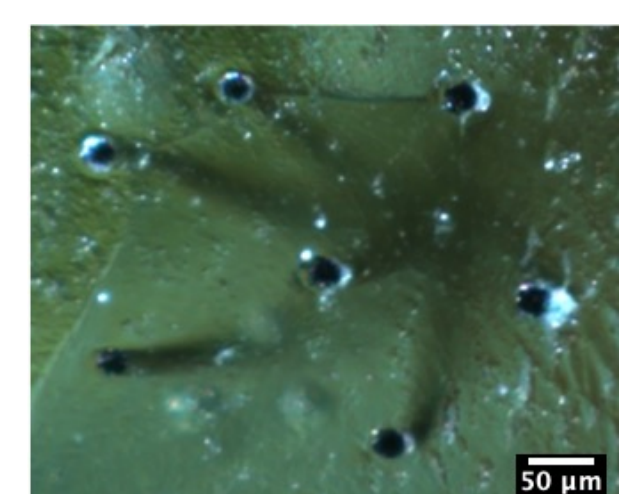
Project Aims

- To fabricate a **microelectrode array** for the simultaneous detection of multiple analytes using E-AB sensor platform and selective aptamer modification.

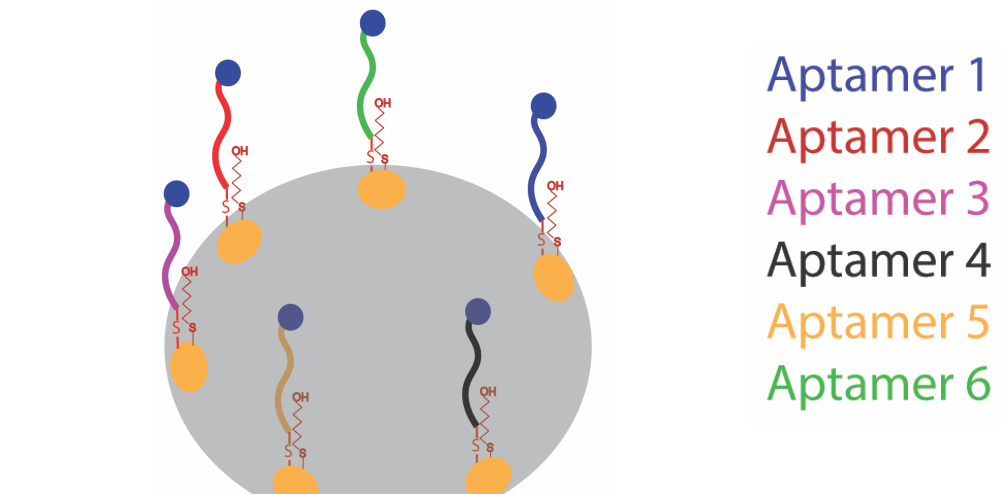
Schematic of anticipated sealed device



Surface of Pt array after polishing

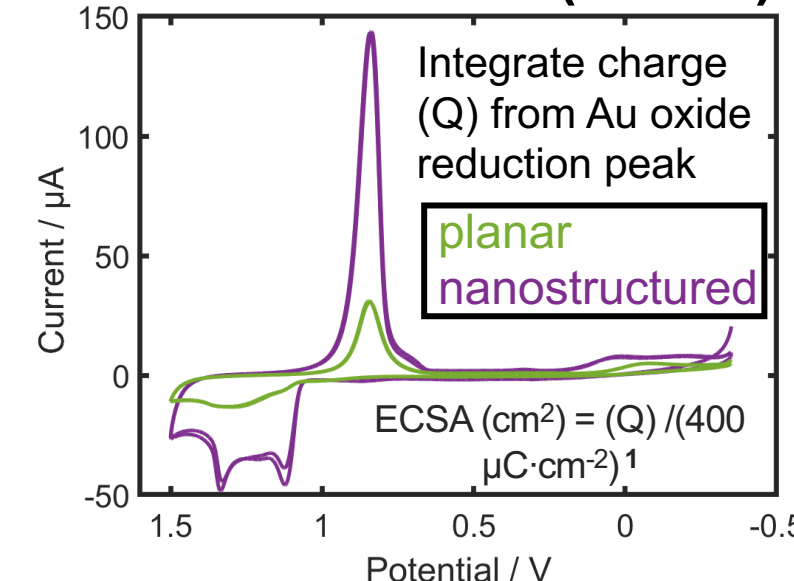


Schematic of Electrode Surface with multiple aptamers

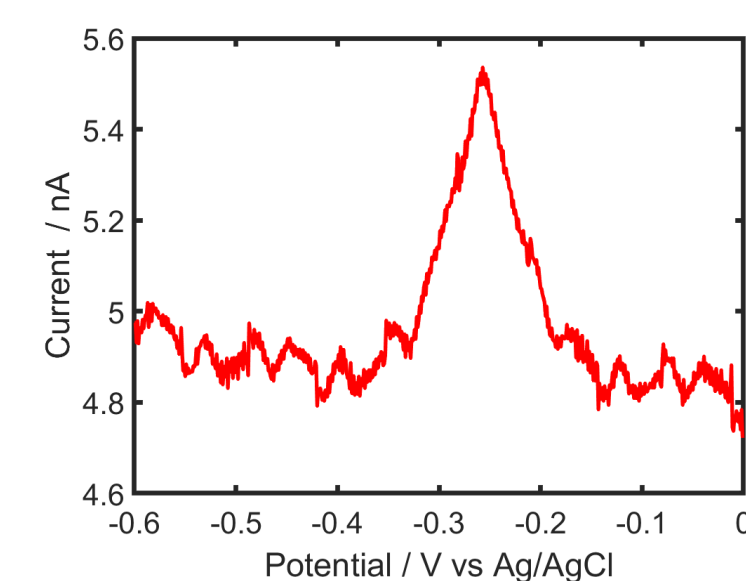


- To better understand the effects of **gold nanostructured microelectrodes** on EAB sensor performance. Once understood, these results can be applied to a microelectrode array.

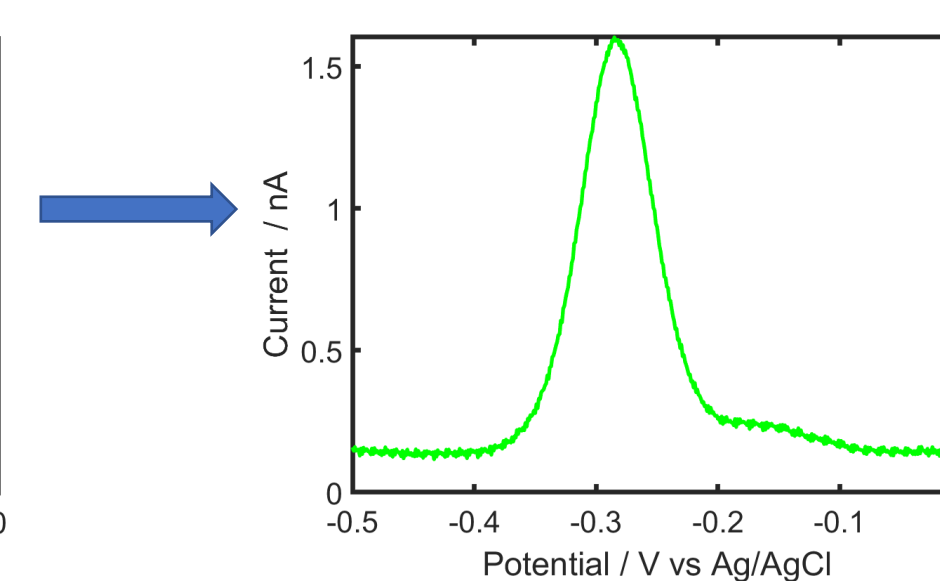
CV in 0.05 M H₂SO₄ to characterize (ECSA)



unmodified

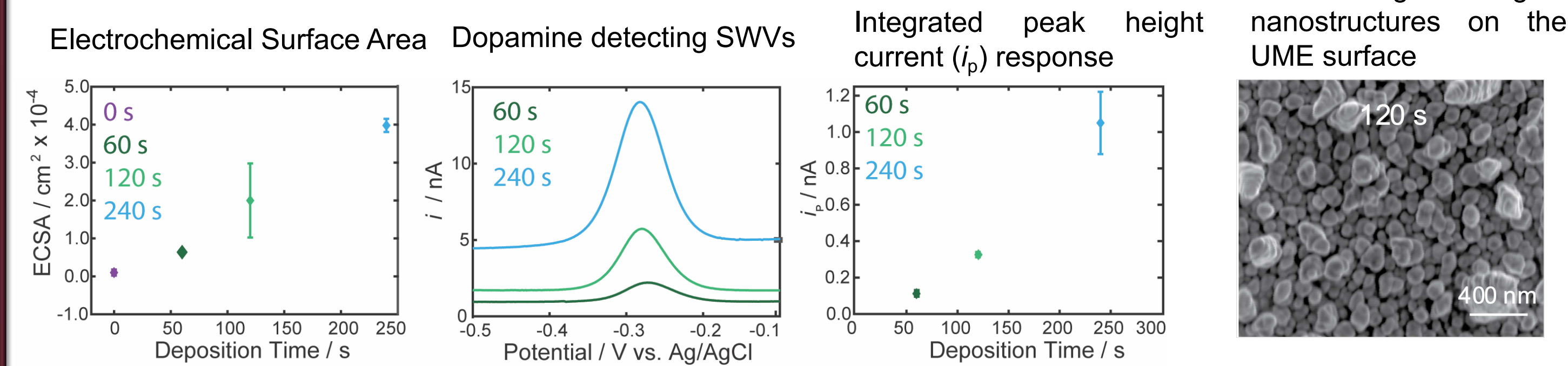


nanostructured

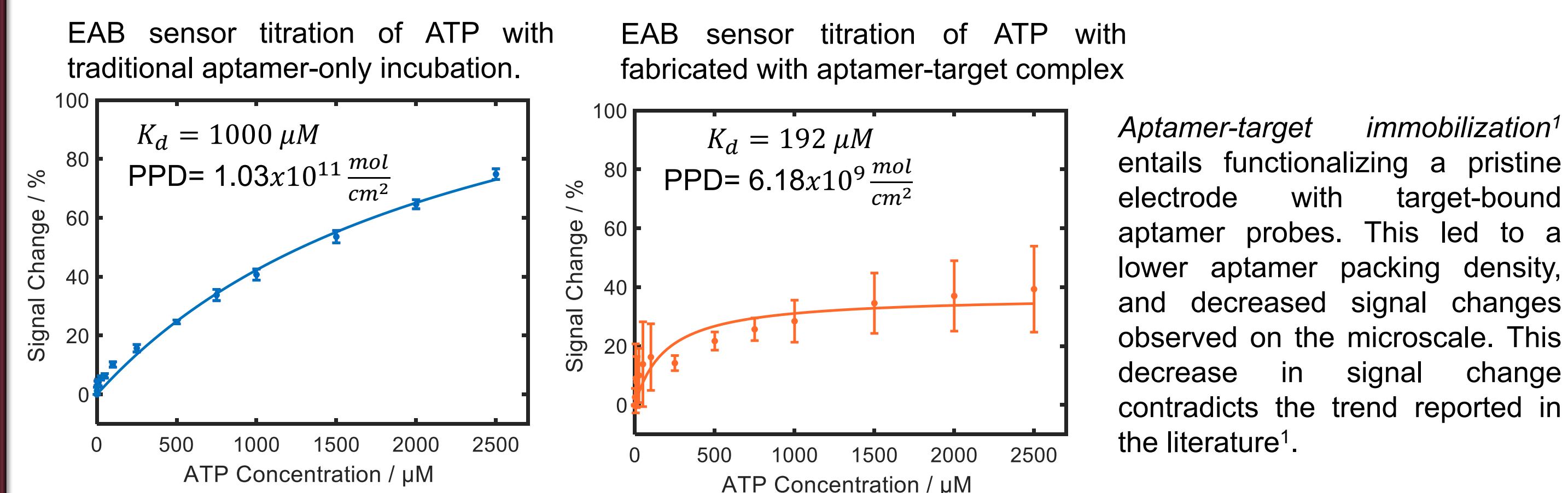


Nanostructured Microscale EAB Sensors

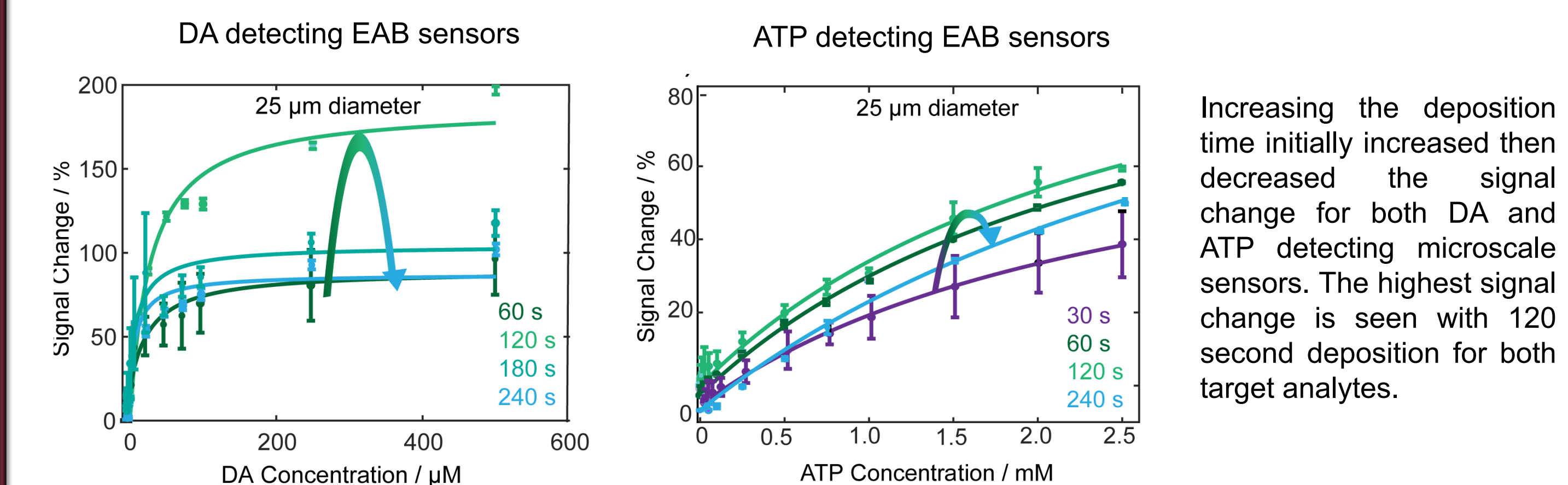
Surface area enhancement via pulsed waveform electrodeposition



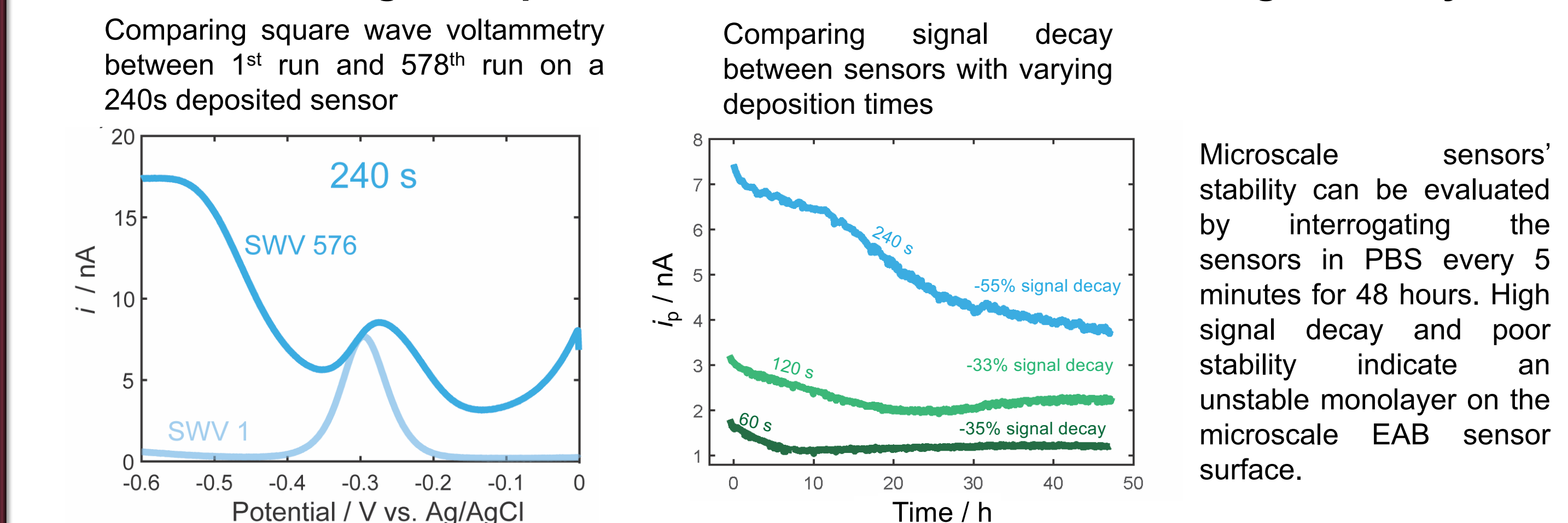
Aptamer-only vs Aptamer-target complex immobilization



Evaluation of nanostructured microscale EAB sensor performance

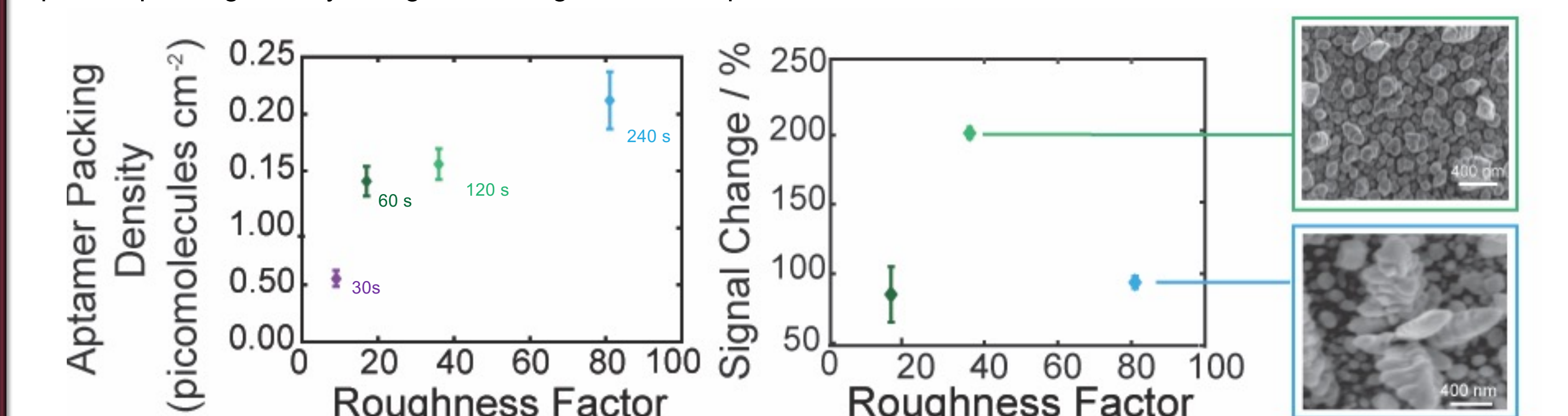


Effects of gold deposition on microscale EAB sensor signal decay



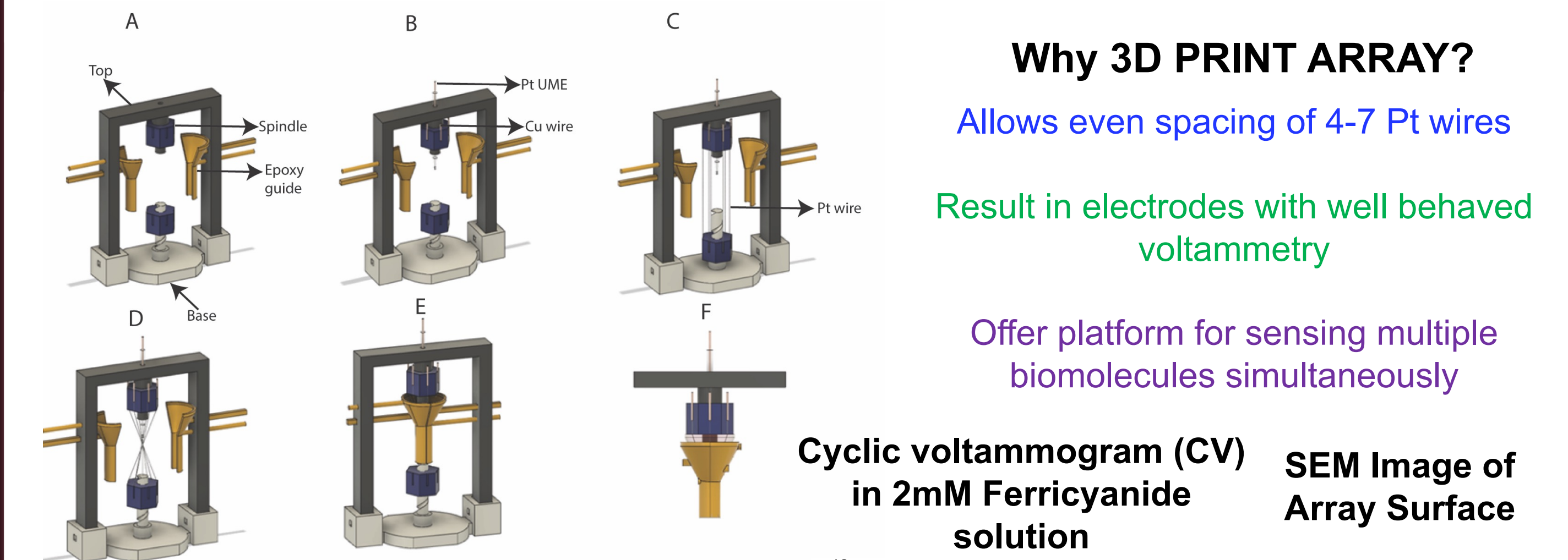
Effects of gold deposition on aptamer probe packing density of the microscale EAB sensor surface

As deposition time increases there is a general increase in aptamer packing density. However, there is an optimal aptamer packing density that gives the highest sensor performance.



Microelectrode Arrays

Fabrication of UME Array via 3D Printed Molds



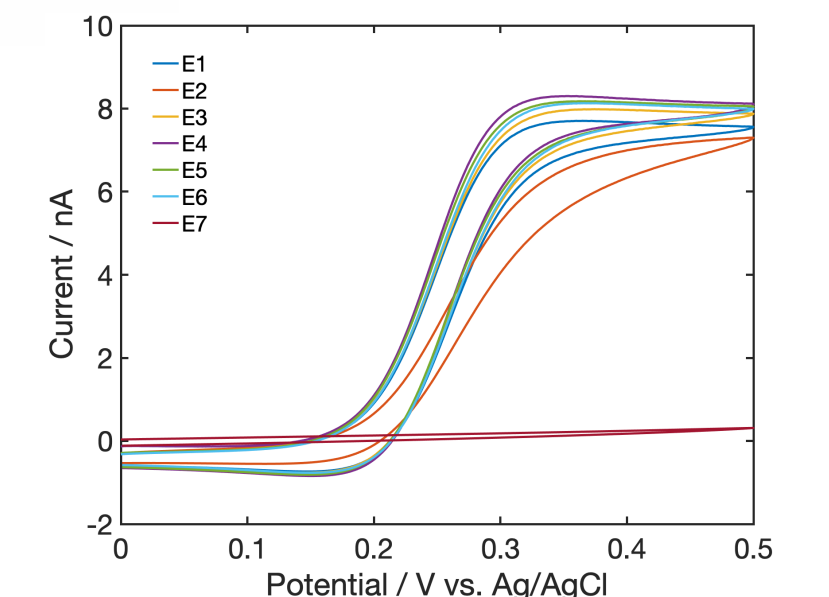
Why 3D PRINT ARRAY?

Allows even spacing of 4-7 Pt wires

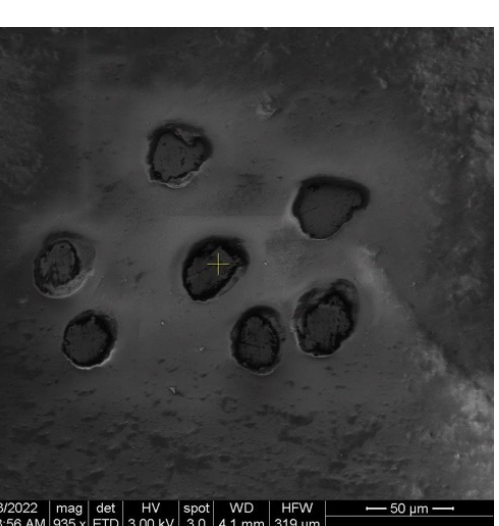
Result in electrodes with well behaved voltammetry

Offer platform for sensing multiple biomolecules simultaneously

Cyclic voltammogram (CV) in 2mM Ferricyanide solution



SEM Image of Array Surface



Array fabrication process via 3D-Print: A: 3D-printed assembly, B: Assembly with central Pt UME and Cu leads in place, C: Assembly with Pt wire soldered to Cu leads, D: Assembly with Pt wires anchored to base by epoxy, E: Closed assembly, F: Externally sealed array to be internally sealed with epoxy

Expected Limiting Current: $I_{lim} = 4nFDac^*$
 $I_{lim} = 6.2725 \times 10^{-9} \text{ nA}$

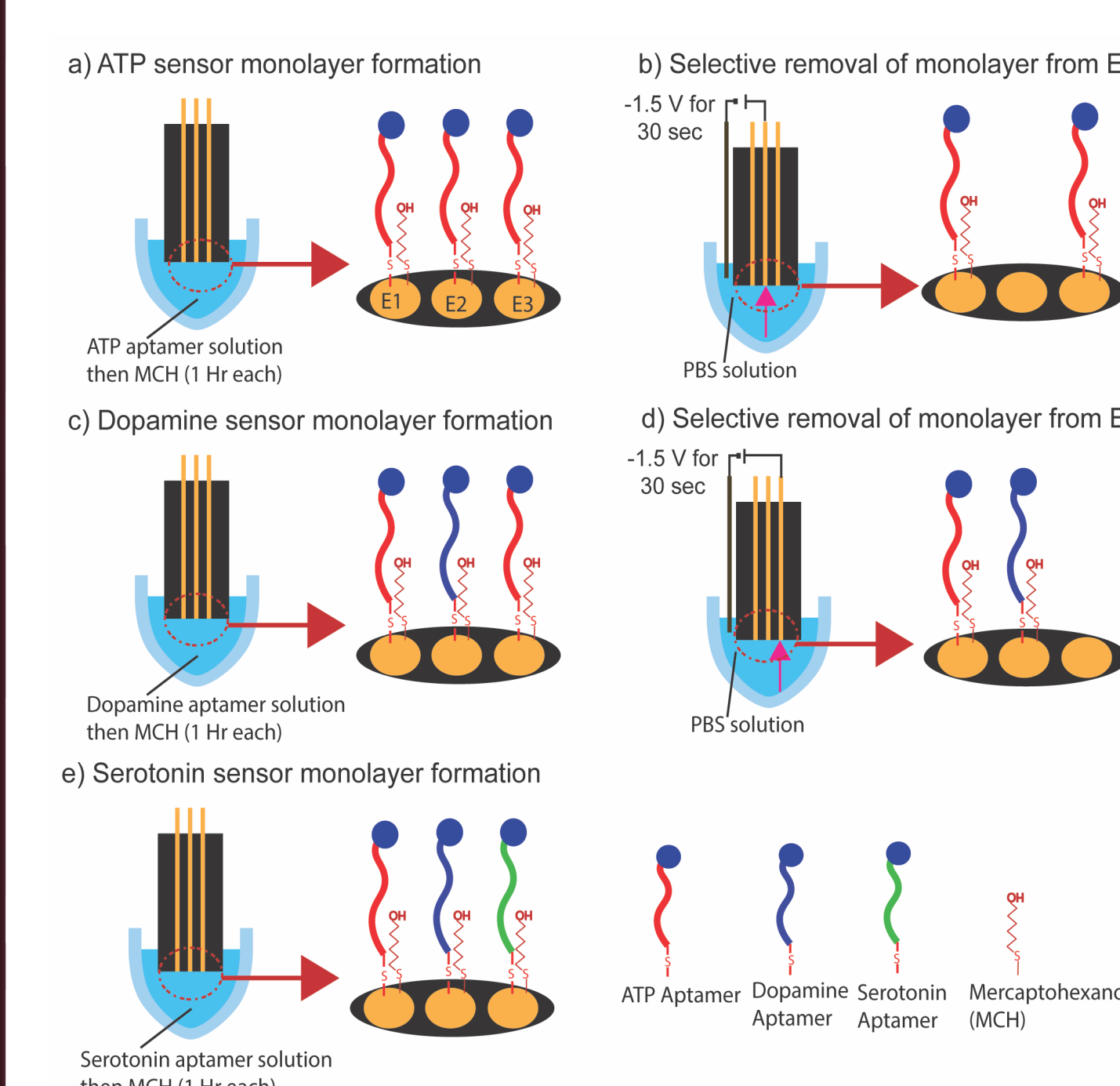
The CV of individual electrodes recorded in ferricyanide solution show well behaved CV with expected limiting current.

Challenges: Reproducible fabrication of array with even inter-electrode spacing and better connectivity of the individual electrodes within the array

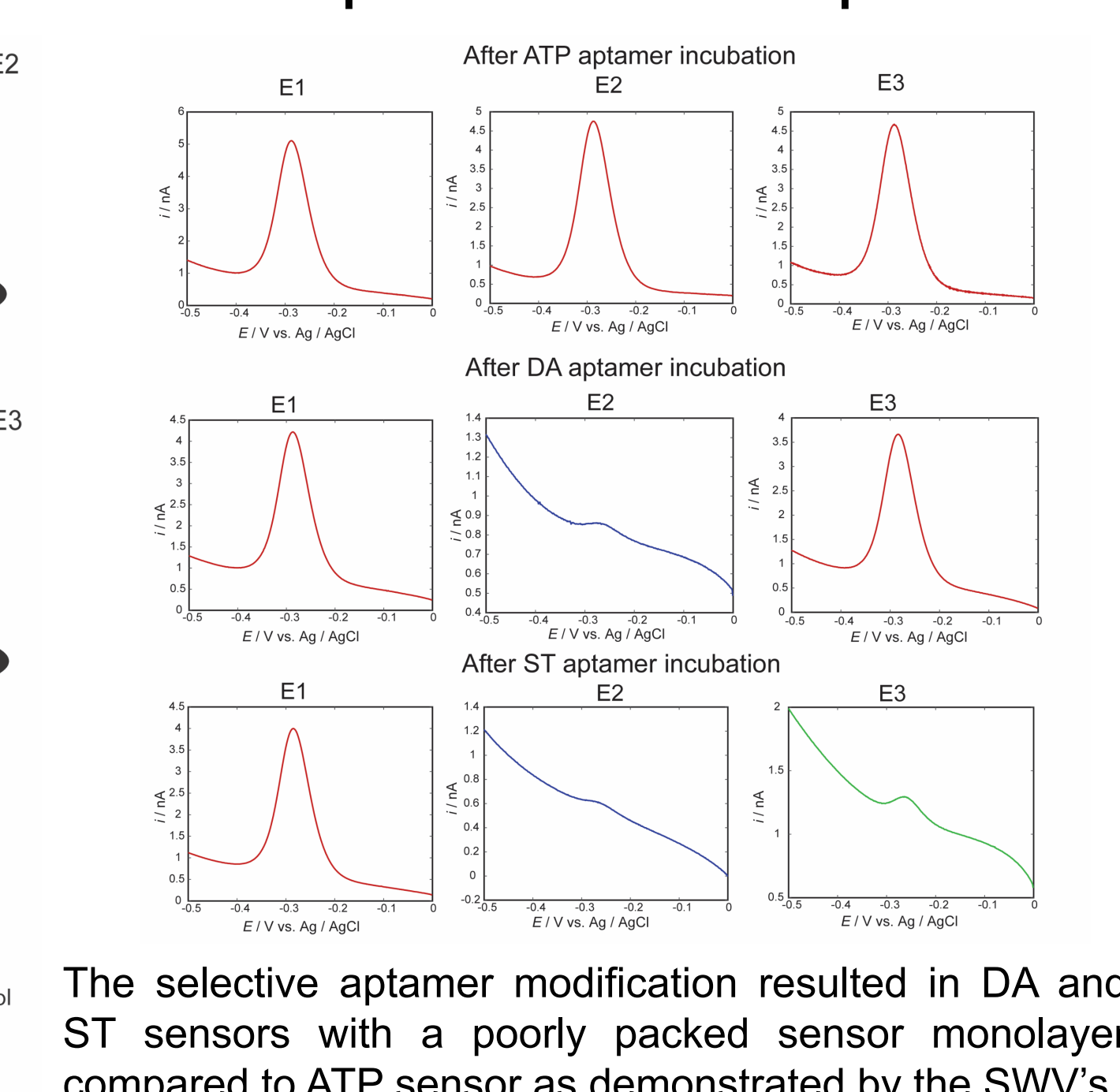
Selective aptamer modifications in the microelectrode array for simultaneous detection of multiple analytes

After the fabrication of the array, individual electrodes within the array can be selectively modified with different aptamers. This will allow the array to be used as a multiplex biosensing platform.

Schematic of selective aptamer modification



SWVs of the fabricated sensors throughout selective aptamer modification process



The selective aptamer modification resulted in DA and ST sensors with a poorly packed sensor monolayer compared to ATP sensor as demonstrated by the SWV's

Future Work

- To fabricate electrode arrays characterized by precise inter-electrode spacing and robust connection of the individual electrodes within the array by adjusting certain fabrication parameters.
- To repeat more experiments on the selective aptamer modification method using the fabricated array to have sensor with stable monolayer.
- To carry out the simultaneous detection of ATP, DA and ST using the array.

Acknowledgements

FSU Startup Funds

Lab website:
<https://www2.chem.fsu.edu/~lazenby/>

References

¹Liu, Y.; Canoura, J.; Alkhamis, O.; Xiao, Y. *ACS Appl. Mater. Interfaces* **2021**, *13* (8), 9491–9499.